Scanning Electron Microscopy (SEM)

Alex Idman

Topics

- Theory of SEM
- What can you see?
- Data interpretation
- Pros & Cons
- Research examples



Picture of a SEM from the nanomicroscopy center



First SEM built in 1937 by Manfred von Ardenne



Theory of SEM

- Uses a focused electron beam to scan the surface of the sample
- Interaction of the beam electrons and the surface atoms cause different kinds of signals that can be then recorded
- Typically samples are in a vacuum, wet conditions possible as well a wide temperature range



Secondary Electrons (SE)

- Inelastic collision between the incoming electron and valence electrons of the sample which ejects the secondary electron
- SE have low energy (2-50 eV) and it's near the surface which makes high resolution imaging possible
- Surface level depth (5-50 nm)
- Topography contrast/Edge detail





Backscattered Electrons (BSE)

- Incoming electrons get deflected by the nucleus instead
- Higher energy electrons compared to SE
- Deflected from deeper parts (10-100 nm)
- Material contrast which is atomic number dependent





SEM Machine

- Electron gun
 - W filament, LaB6
- Condenser lenses
 - Electromagnetic beam focusers
- Apeture
 - Controls the probe current
- Coils
 - Controls the beam position on the surface
- Magnification range of 10x to 1000000x
- Can go to resolutions under 1 nm



What can you see?





Volcanic ash, SE vs BSE

X-Rays



Astigmatism







Ways to correct for astigmatism are:

- Higher magnitude
- Focus the image using objective lens control
- Sharpen the image using stigmator coils
 - Stigmator coils create a compensating field opposing the elliptical main beam to make it spherical

- Wobbling causes the image to move when you try to focus it
- Happens when apeture is not aligned with the electron beam
- Correction happens by switching the current to the objective lens constantly and correcting the apeture to minimize image movement





- Working distance affects depth of field, resolution, edge contrast
- Working distance means the physical distance between the beam and the sample



 Accelerating voltage affects surface details, resolution, edge contrast and sample damage



Diameter of the final beam affects the resolution and depth of field





Small spot size

Large spot size

Pros & Cons

- SEM is good for imaging samples that are too thick for TEM
- Variety of information gained through different signals
- Easy to operate
- Size of SEMs can get large
- Costs can get ridiculously high... (starting from 50k € to over 1 million €)
- Expensive to operate

Research examples – Sr2FeMoO6

- Tunneling magnetoresistance effect (TMR)
- It suggests that TMR affects the Fe/Mo ordering
- Superparamagnetic (SP) component present in upper graph
- No clear explanation but believed to be by smallest grain fluctuations due to low coercive force and anisotropy energy
- Wet-chemical process for precursor preparation and encapsulation technique combined achieve a high degree of ordering



Sr2FeMoO6 - continued

- Picture b) blurry, could be because of wobble, unfocus
- Picture a) big contrast differences



"Simple and Efficient Route to Prepare Homogeneous Samples of Sr₂FeMoO₆ with a High Degree of Fe/Mo Order", Y. H. Huang, J. Lindén, H. Yamauchi, M. Karppinen., *Chem. Mater. 16, 4336-4342 (2004)*.

Research examples - Sr2FeMoO6 continuation paper

- TMR is explained to be caused by intra-granular two-dimensional defects and grain boundaries/impurity-phase boundaries
- Mix of high degree ordered large grains and lower degree ordered small grains which enhanced the magnetoresistance



"Large low-field magnetoresistance effect in Sr₂FeMoO₆ homocomposites", Y. H. Huang, J. Lindén, H. Yamauchi, M. Karppinen, *Appl. Phys. Lett.* 86, 072510 (2010).